

Improvement in High-Frequency Properties of Beam Halo Monitor using Diamond Detectors for SPring-8 XFEL

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1GeV Linac

8GeV Storage Ring

XFEL Exp. and -Research Bld. 8GeV Booster Synchrotron

250MeV SCSS Test Accelerator

XFEL Undulator Bld.

XFEL Accelerator Bld.

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1. Introduction

Motivation of this Work Required Detection Limit

- 2. Prototype of Beam Halo Monitor The Diamond Detector and the Beam Tests The Prototype and the Beam Tests
- Improvement in High-Frequency Properties
 Structure of RF fingers and other devices
 Beam Test of the RF Shield Evaluation Device (Test chamber)
- 4. Mechanical Design of the Beam Halo Monitor
- 5. Summary



1. Introduction

Motivation of this work

Goal of Detection Limit



We are planning to install a <u>beam halo monitor</u> in front of the in-vacuum undulators.

Demagnetization of the permanent magnets will be occurred under electron irradiation. The halo of electron beam may be broadened by some changes of beam conditions, and may hit the magnets.

The intensity of the halo of the electron beam must be monitored during machine operation, and an electron injector must be halted when the intensity of the halo exceeds a threshold.

Sensors in front of the undulator magnets



Beam halo is existing and the profile is asymmetric.

Tolerance of demagnetization rate of undulator magnets 1 % / 10 year

 \rightarrow Tolerance of incident electron on the magnets

 $4 \times 10^{14} e^{-} / 10 year$ (based on the experimental results)

 \rightarrow Required detection limit < 2 × 10⁴ e⁻ / pulse

($60Hz \times 24hrs \times 365day \times 10$ year $\Rightarrow 1.9 \times 10^{10}$ pulse)

cf. Number of electron through undulators $2 \times 10^9 e^-$ / pulse (0.3nC/pulse)

 \rightarrow Tolerance of electron loss rate < 10⁻⁵



2. Prototype of Beam Halo Monitor

The Diamond Detector and the beam tests at 8GeV Booster Synchrotron

The Prototype and the beam tests at 250MeV SCSS Test Accelerator



Properties of diamond

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- High radiation hardness (durable)
- Sufficient heat resistance (bakable)
- High insulation resistance (low dark current)

Manufactured by Kobelco

Pulse-by-pulse measurement suppresses the background

noise efficiently, especially in the facilities having extremely high intense beam but low repetition rate, such as X-ray free electron lasers.

Unipolar Pulse shape

Beam test of the diamond detector

Linearity



FWHM=0.33nsec

SPring-8

Charge signal is 140 fC at the incident of 10^4 electrons.

Charge from the diamond detector is proportional to the number of electrons in the range of from 10^3 to 10^7 /pulse.

For use as an interlock sensor, practical detection limit is about 2×10^3 /pulse.

SPring 8 Photographs of the Prototype



Kapton coaxial cable

SMA connectors



Seen from on the axis

Installed at 250MeV SCSS Test Accelerator



The active area of the diamond detector was irradiated directly with the beam core $(3 \times 10^4 \text{ e})$.



The unipolar pulse shape can be observed clearly.





The effect of induction current can be smeared by using Low Pass Filters, so the net signal from e-h pairs that is created by the halo part of the electron beam can be measured.

The beam core passes through near the edge of diamond detectors.

SPring-8 Effect of secondary electrons and radiation





The profiles of electron spread by bremsstrahlung and electron scattering is assumed to be broad. On the contrary, the amount of signal charge at the vertical position over +/-2 mm is lower than the detection limit. So we think that the signal cause of bremsstrahlung and secondary electrons is negligibly small.

after 50 MeV Injector

5. Effect on the oscillation of FEL



The intensity of laser oscillation is not to be effected if the distance from the beam center and the diamond detector is more than 0.6 mm.



3. Improvement in High-Frequency Properties

Structure of RF fingers and other devices

Beam Test of the RF Shield Evaluation Device (test chamber)

Structure of RF finger and other devices



Beam Test with RF Shield Evaluation Device

The beam tests of the RF shield evaluation device, which adopts the above-mentioned items, have been performed at 250 MeV SCSS test accelerator.



The effect of wake field is reduced by of 1/10.

The induced current can be reduced further by improving the shape of the RF fingers.



4. Mechanical Design of

Beam Halo Monitor







Next step:

The diamond detectors will be covered by RF fingers.

- Reduce the wake field for preserving beam quality.

- Mute the induction current that emerges in the signal of the diamond detector.

- Protect the diamond detector from the intense wake field.



5. Summary

1. Purpose of this work

- to protect undulator magnets against radiation damage
- using the beam halo monitor equipped with the diamond detectors
- adopting pulse measurement for enhancing S/N ratio
- 2. Prototype of Beam Halo Monitor
 - Practical detection limit is about 2×10^3 /pulse. (10⁻⁶ of 0.3nC)
 - Feasibility had been demonstrated at 250MeV SCSS Test Acc.
- 3. Improvement in High-Frequency Properties
 - RF fingers and other devices were applied.
 - Beam test was carried out with the RF Shield Evaluation Device.
 - The induced current was reduced by a factor of 1/10.
 - Mechanical design has been completed.
- 4. Next step
 - Further modifications on RF fingers will be added, and will be tested soon.